



UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
UNITED STATES PATENT AND TRADEMARK OFFICE
P.O. Box 1450
ALEXANDRIA, VA 22313-1450
www.uspto.gov

MUETING, RAASCH & GEBHARDT, P.A.
P.O. BOX 581415
MINNEAPOLIS MN 55458

COPY MAILED

NOV 16 2004

OFFICE OF PETITIONS

Applicant: Vaartstra
Appl. No.: 10/229,802
Filing Date: August 28, 2002
U.S. Patent No.: 6,794,284
Issue Date: September 21, 2004
Title: SYSTEMS AND METHODS FOR FORMING REFRACTORY METAL NITRIDE LAYERS USING DISILAZANES
Attorney Docket No.: 150.01280101
Pub. No.: US 2004/00043604 A1
Pub. Date: March 4, 2004

This is in response to the request for correction of patent application publication under 37 CFR 1.221(b), which was filed on March 4, 2004.

The request is DISMISSED as moot.

The instant request identifies numerous errors in the published patent application publication. Since the application has already issued as U.S. Patent No. 6,794,284 on September 21, 2004, the request is deemed moot.

Inquiries relating to this matter may be directed to the undersigned at (571) 272-7709.

Mark O. Polutta
Office of Patent Legal Administration
Office of the Deputy Commissioner
for Patent Examination Policy